

Notice of References Cited		Application/Control No. 10/736,480	Applicant(s)/Patent Under Reexamination QI ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0084727	04-2005	Kiefer et al.	429/033
*	B	US-2001/0031387	10-2001	Takeda et al.	429/20
	C	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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